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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Yuichiro SASAKI et al.

Mail Stop: PCT

Serial No. NEW

Attorney Docket No. 2005_0321A

Filed April 27, 2005

METHOD OF PLASMA DOPING [Corresponding to PCT/JP2003/014633

Filed November 18, 2003]

THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT

ACCOUNT NO. 23-0975

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

la.

Pursuant to the provisions of 37 CFR 1.56, 1.97 and 1.98, Applicants request consideration of the references listed on attached form PTO-1449 and any additional information identified below in paragraph 3. A legible copy of each reference listed on the Form PTO-1449 is enclosed, except a copy is not provided for:

[]	each U.S. Patent and U.S. Patent application publication;
0	each reference previously cited in the international application PCT/; and/or
0	each reference previously cited in prior parent application Serial No.
[X] TI	his Information Disclosure Statement is submitted:

within three months of the filing date (or of entry into the National Stage) of the above-entitled application, or

before the mailing of a first Office Action on the merits or the mailing of a first Office Action after the filing of an RCE,

and thus no certification and/or fee is required.

ATTACHMENT D

1b. [] This Information Disclosure Statement is submitted

after the events of above paragraph 1a and prior to the mailing date of a final Office Action or a Notice of Allowance or an action which otherwise closes prosecution in the application, and thus:

- (1) [] the certification of paragraph 2 below is provided, or
- (2) [] the fee of \$180.00 specified in 37 CFR 1.17(p) is enclosed.
- 1c. [] This Information Disclosure Statement is submitted:

after the mailing date of a final Office Action or Notice of Allowance or action which otherwise closes prosecution in the application, and prior to payment of the issue fee, and thus:

the certification of paragraph 2 below is provided, and

the fee of \$180.00 specified in 37 CFR 1.17(p) is enclosed.

- 2. It is hereby certified
 - a. [] that each item of information contained in this Information Disclosure
 Statement was first cited in any communication from a foreign patent office in a
 counterpart foreign application not more than three months prior to the filing of
 the Statement, or
 - b. [] that no item of information contained in the Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application and, to the knowledge of the person signing the certification after making reasonable inquiry, was known to any individual designated in §1.56(c) more than three months prior to the filing of the Statement.
- 3. [] Consideration of the following list of additional information (including any copending or abandoned U.S. application, prior uses and/or sales, etc.) is requested.
- 4. For each non-English language reference listed on the attached form PTO-1449, reference is made to:

- a full or partial English language translation submitted herewith, a. []
- an International Search Report (in the English language) submitted herewith,
- the concise explanation contained in the specification of the present application c. [] at page,
- d. [X] the concise explanation set forth in the attached English language abstract,
- the concise explanation set forth below or on a separate sheet attached to the e. [] reference:
- [X] An International Search Report citing one or more of the references is enclosed. 5.

Respectfully submitted,

Yuichiro SASAKI et al.

Attorney for Applicants

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April 27, 2005

JC20 Rec'd PCT/PTO 27 APR 2005 1, INFORMATION DISCLOSURE STATEMENT Sheet 1 of 1 電的7532768 ATTY DOCKET NO. FORM PTO 1449 (modified) 2005_0321A U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE **APPLICANT** Yuichiro SASAKI et al. LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary) GROUP **FILING DATE** Date Submitted to PTO: April 27, 2005 April 27, 2005 U.S. PATENT DOCUMENTS SUBCLASS DOCUMENT DATE NAME CLASS FILING DATE IF *EXAMINER **APPROPRIATE** NUMBER INITIAL AA AB AC AD ΑE AF AG AH ΑI FOREIGN PATENT DOCUMENTS SUBCLASS TRANSLATION DOCUMENT DATE COUNTRY CLASS NUMBER YES NO abstract ΑJ 10-12890 1-16-98 Japan AK 1 054 433 11-22-00 Europe Х abstract AL 2002-170782 6-14-02 Japan WO AM 02/080254 10-10-02 abstract

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OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)

AO Bunji MIZUNO et al., "Plasma Doping into the Side-Wall of a Sub-0.5 µm Width Trench", Extended Abstracts of the 19th Conference on Solid State Devices and Materials, Tokyo, 1987, pp. 319-322

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EXAMINER

DATE CONSIDERED